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RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
ART UNIT 1753

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TAKAHARU KONDO ET AL.

Application No.: 09/866,665

Filed: May 30, 2001

For: SILICON-TYPE THIN FILM  
FORMATION PROCESS, SILICON  
TYPE THIN FILM, AND  
PHOTOVOLTAIC DEVICE

Examiner: B.L. Mutschler

Art Unit: 1753

July 25, 2003

Commissioner for Patents  
Mail Stop: AF  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE AFTER FINAL ACTION  
AND PETITION FOR EXTENSION OF TIME

Sir:

Applicants petition to extend the time for response to the Office Action dated  
March 25, 2003, to and including July 25, 2003. A check in the amount of \$110.00 for payment

I hereby certify that this correspondence is being deposited with the United  
States Postal Service as first-class mail in an envelope addressed to:  
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

July 25, 2003  
(Date of Deposit)

Lock See Yu-Jahnes (Reg. No. 38,667)  
(Name of Attorney for Applicants)

(Signature)

July 25, 2003  
(Date of Signature)

07/30/2003 HBERHE 00000018 09866665  
01 FC:1251 110.00 OP

of the extension fee is enclosed. Please charge any additional fee required for the extension, or credit any overpayment, to Deposit Account 06-1205.

In response to the Office Action, the Examiner is respectfully requested to consider the following: